

# Accurate Self-Configuration of Rectangular Multiport Interferometers

Ryan Hamerly<sup>1,2</sup>, Saumil Bandyopadhyay<sup>1</sup>, and Dirk Englund<sup>1</sup>  
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<sup>1</sup> *Research Laboratory of Electronics, MIT, 50 Vassar Street, Cambridge, MA 02139, USA*

<sup>2</sup> *NTT Research Inc., Physics and Informatics Laboratories, 940 Stewart Drive, Sunnyvale, CA 94085, USA*

**Abstract**—Multiport interferometers based on integrated beamsplitter meshes are widely used in photonic technologies. While the rectangular mesh is favored for its compactness and uniformity, its geometry resists conventional self-configuration approaches, which are essential to programming large meshes in the presence of fabrication error. Here, we present a new configuration algorithm, related to the  $2 \times 2$  block decomposition of a unitary matrix, that overcomes this limitation. Our proposed algorithm is robust to errors, requires no prior knowledge of the process variations, and relies only on external sources and detectors. We show that self-configuration using this technique reduces the effect of fabrication errors by the same quadratic factor observed in triangular meshes. This relaxes a significant limit to the size of multiport interferometers, removing a major roadblock to the scaling of optical quantum and machine-learning hardware.

Large-scale programmable photonic circuits are the cornerstone of many emerging technologies, including quantum computing [1, 2], machine learning acceleration [3–5], and microwave photonics [6, 7]. One such circuit—the universal multiport interferometer, which functions as a linear optical input-output device with a programmable transfer matrix (Fig. 1)—is of special importance due to its generality and broad range of applications [8]. The most scalable designs involve meshes of Mach-Zehnder interferometers (MZIs): while the triangular RECK mesh (Fig. 1(a)) was initially employed and is straightforward to configure [9], more recently work has shifted to the CLEMENTS rectangle (Fig. 1(b)), which offers clear advantages of compactness, path-length uniformity, and reduced sensitivity to loss [10]. Much recent study has focused on scaling [11, 12] and optimizing [13–16] MZI meshes based on the CLEMENTS design.

A major challenge to scaling MZI meshes is the presence of component errors due to fabrication imperfections. Errors cause each MZI transfer matrix to deviate from its programmed value (Fig. 1(c)); since the overall circuit is a cascade of MZIs with  $O(N)$  depth, the total error in the transfer matrix scales as  $O(\sqrt{N})$ , where  $N$  is the circuit size (assuming uncorrelated errors). At large mesh sizes, these errors (if left uncorrected) place

unreasonable constraints on fabrication tolerances, ultimately limiting the scaling of multiport interferometers. Error-correction techniques are therefore critical for large-scale programmable photonics. Global optimization [13–15] and in-situ training [17] are promising in principle, but computationally inefficient and device-specific. Local per-MZI correction is also effective, but requires prior characterization of the device errors [18]. A number of efficient “self-configuring” algorithms have been proposed [19–21], but these generally only work for triangular meshes and require large numbers of internal power monitors [22], a significant addition in hardware complexity. Recently, we proposed an efficient error-correction algorithm that does not require internal detectors or accurate pre-characterization [23]. However, this algorithm only works for triangular (i.e. RECK) meshes, which excludes the more efficient CLEMENTS design.

In this Letter, we present a new self-configuring strategy that is naturally adapted to the CLEMENTS design and requires no additional hardware complexity beyond external sources and (coherent) detectors. This algorithm proceeds by configuring the diagonals of the mesh, starting at the corners, in a manner that progressively zeroes out the elements of a target matrix through a sequence of Givens rotations. Numerical experiments on imperfect MZI meshes show that our algorithm is stable and robust, and reduces errors by at least a quadratic factor (while sufficiently small errors are corrected exactly), consistent

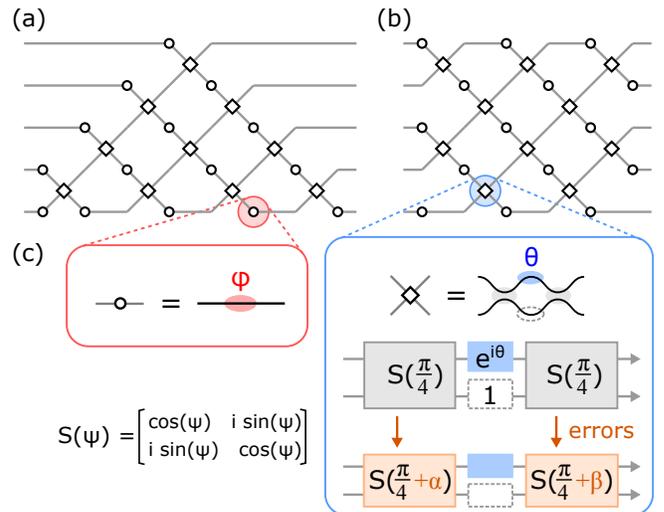


Figure 1: (a) RECK and (b) CLEMENTS  $5 \times 5$  MZI meshes. (c) Tunable building blocks: MZI and phase shifter. Effect of errors on MZI transfer function.

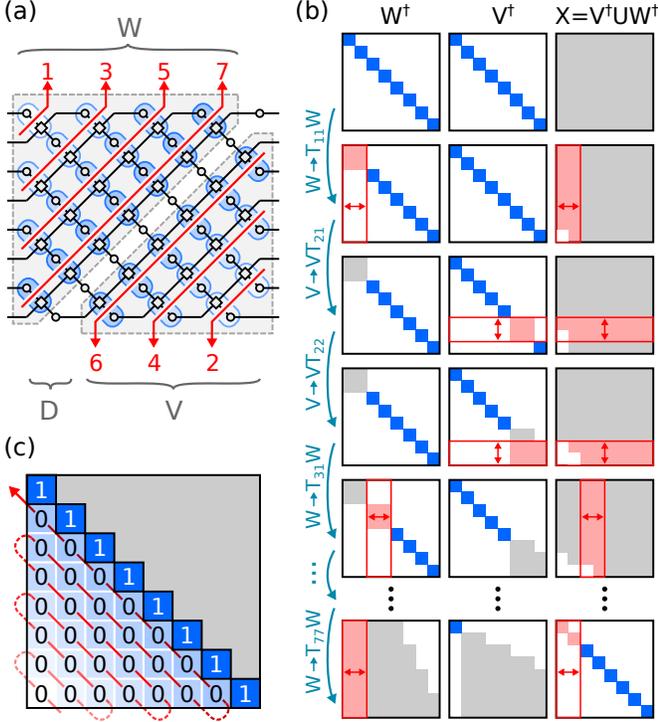


Figure 2: (a) CLEMENTS mesh and order of MZI configuration. (b) Building up the matrices  $V, W$  in a sequence of Givens rotations to diagonalize  $X = V^\dagger U W^\dagger$ . (c) Order of matrix elements zeroed by the procedure.

with the behavior observed for triangular meshes [23]. This significantly relaxes the scaling constraints posed by fabrication imperfections in realistic MZI meshes. As an example, we consider the application to optical neural networks and show how this correction scheme provides a path to overcome the no-go results of Ref. [24].

Our procedure is based on the diagonalization of a unitary using  $2 \times 2$  Givens rotations [10], which we review here for clarity. Following Fig. 2(a), divide the mesh along the rising diagonal so that its transfer matrix becomes  $U = VDW$ , where  $D$  is a phase screen and  $V$  and  $W$  represent the upper and lower triangles, given by:

$$\begin{aligned} V &= (T_{21}T_{22})(T_{41} \dots T_{44}) \dots (T_{N-2,1} \dots T_{N-2,N-2}) \\ W &= (T_{N-1,N-1} \dots T_{N-1,1}) \dots (T_{33} \dots T_{31})(T_{11}) \end{aligned} \quad (1)$$

where  $T_{mn}$  is the  $2 \times 2$  block unitary corresponding to the  $n^{\text{th}}$  crossing (MZI / phase-shift pair) of the  $m^{\text{th}}$  diagonal. Following the order in the figure, we “build up” the matrices  $(V, W)$  one block at a time while keeping track of  $X = V^\dagger U W^\dagger$ . Fig. 2(b) shows the first few steps of this process. Updates to  $W \rightarrow T_{mn}W$  right-multiply  $X \rightarrow XT_{mn}^\dagger$ , and the phases of  $T_{mn}$  are chosen to zero an element in the lower-left corner of  $X$ . Likewise, updates to  $V \rightarrow VT_{mn}$  left-multiply  $X \rightarrow T_{mn}^\dagger X$ . Following the order in Fig. 2(c), this procedure zeroes all elements

in the lower-left triangle of  $X$ , enforcing diagonality. The remaining phases are read off from the diagonal elements.

While this procedure correctly sets the phases  $(\theta, \phi)$  for an ideal CLEMENTS mesh, it does not work in the presence of errors because the relationship between  $(\theta, \phi)$  and  $T_{mn}$  also depends on the splitting angle imperfections  $(\alpha, \beta)$  (Fig. 1(c)), which are unknown. Here, we describe the procedure for programming CLEMENTS in the presence of errors:

1. Initialize the MZIs to approximate the cross state ( $\theta = 0$ ). An ideal cross state is not possible with errors, but an approximation will be fine.
2. Configure the crossings in the order given by Fig. 2(a). For each crossing in  $W$  [resp.  $V$ ]:
  - (a) Perform the Givens rotation  $X \rightarrow XT_{mn}^\dagger$  [resp.  $X \rightarrow T_{mn}^\dagger X$ ] that zeroes the next element of  $X_{ij}$  in the sequence Fig. 2(c) (note  $(i, j) \neq (m, n)$ ).
  - (b) Update  $W \rightarrow T_{mn}W$  [resp.  $V \rightarrow VT_{mn}$ ].
  - (c) Send input  $\vec{a}_{\text{in}} = \vec{w}_j^*$  (the  $j^{\text{th}}$  column of  $W^\dagger$ ) into the device, Fig. 3. The output  $\vec{a}_{\text{out}}(\theta, \phi)$  depends on the phases being configured. Set  $(\theta, \phi)$  to zero the inner product  $\langle \vec{v}_i | \vec{a}_{\text{out}}(\theta, \phi) \rangle$ , where  $\vec{v}_i$  is the  $i^{\text{th}}$  column of  $V$ .
3. Finally, set the diagonal: for each  $i$ , inject  $\vec{a}_{\text{in}} = \vec{w}_i^*$  and adjust  $\phi$  to satisfy  $\arg(\langle \vec{v}_i | \vec{a}_{\text{out}}(\phi) \rangle) = 0$ .

Of the main loop (Step 2), parts (a-b) are just a restatement of the CLEMENTS factorization [10]. However this

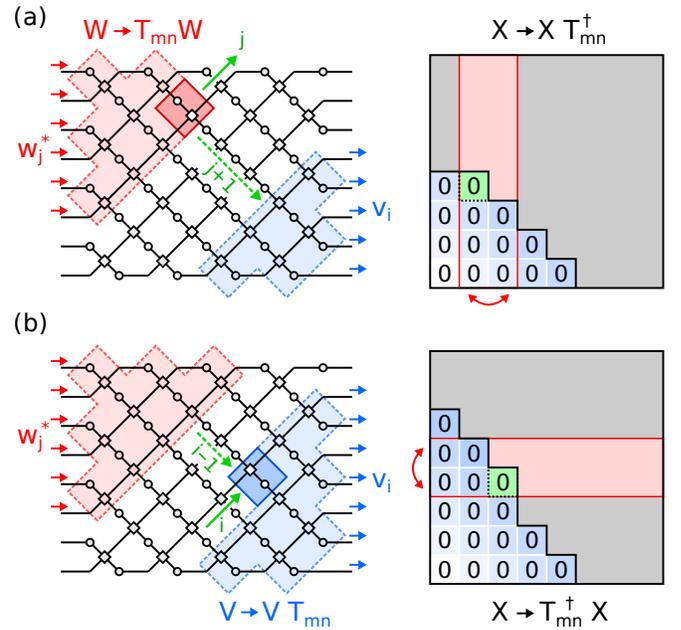


Figure 3: Programming a physical CLEMENTS mesh in the presence of errors. (a) Procedure to set phases for a crossing in  $W$ . (b) Procedure for  $V$ .

is performed merely to keep track of matrices ( $V, W$ ); we do not use the  $(\theta, \phi)$  provided by the algorithm. Instead, Step 2(c) uses physical measurements find the correct phases in the presence of hardware errors. This step, which corresponds to zeroing the matrix element  $X_{ij} = v_i^* U w_j^*$  of the physical hardware, is visualized in Fig. 3:

1. When configuring an  $W$  (Fig. 3(a)), we input  $\vec{a}_{\text{in}} = \vec{w}_j^*$  and program  $(\theta, \phi)$  to direct all the light to intermediate output  $j$  (solid arrow), zeroing the power that goes to  $j + 1$  (dashed arrow). We do not have access to these intermediate outputs, but  $j + 1$  connects to the input  $i$  of  $V$ ; therefore  $\langle \vec{v}_i | \vec{a}_{\text{out}} \rangle$  is a valid proxy for this field and zeroing it correctly configures the red block to match  $W$ .
2. When configuring  $V$  (Fig. 3(b)), we want  $\vec{v}_i$  to be the output from light at intermediate port  $i$  (solid arrow); therefore, the output from light at port  $i - 1$  (dashed arrow) should be orthogonal to  $\vec{v}_i$ . We excite this field by inputting  $\vec{w}_j^*$ ; any errors in the unconfigured mesh will hit downstream inputs  $k < i - 1$ , but will not pollute input  $i$ . Therefore zeroing  $\langle \vec{v}_i | \vec{a}_{\text{out}} \rangle$  correctly configures the blue block of the mesh to match  $V$ , provided  $W$  is properly configured.

It is relatively straightforward to extend this procedure to triangular meshes, as described in the Supplementary Information [25, Sec. S1].

To test this algorithm, we performed numerical experiments on CLEMENTS meshes of size up to  $128 \times 128$ . The algorithms were implemented in PYTHON and are available as part of the MESHES package [26]. We consider an error model based on imperfections in splitter angles  $\alpha, \beta$  (Fig. 1(c)), as these are the dominant effect of fabrication error in MZI-based silicon photonic circuits. For simplicity, consider the case of uncorrelated Gaussian errors so that the error magnitude can be characterized by a single variable  $\sigma = \langle \alpha \rangle_{\text{rms}} = \langle \beta \rangle_{\text{rms}}$  (the case of correlated errors is treated in the Supplementary Information [25, Sec. S2]; the qualitative results are the same because most correlations cancel out in ensemble averaging [23]). Target matrices are sampled uniformly over the Haar measure [27, 28]. As a figure of merit, we consider the normalized matrix error  $\mathcal{E} = \langle \|\Delta U\| \rangle_{\text{rms}} / \sqrt{N}$ . For unitary matrices,  $\mathcal{E} \in [0, 2]$  corresponds to the average relative error of a given matrix element  $U_{ij}$ .

In the uncorrected case, each MZI introduces a mean error  $\langle \|\Delta U\| \rangle_{\text{rms}} = \sqrt{2}\sigma$ . These errors add in quadrature, leading to an overall normalized error  $\mathcal{E}_0 = \sqrt{2N}\sigma$ , which grows with mesh size. This is understandable given that a circuit depth that grows as  $O(N)$ , with each layer contributing  $O(\sigma)$  error and the layers adding in quadrature. Fig. 4(a) plots the error as a function of  $\sigma$  for a  $64 \times 64$  mesh, both without error correction (red) and with our

algorithm (blue). The algorithm always improves the matrix fidelity, but there are two distinct regimes: for small  $\sigma$ , the error approaches machine precision, as errors can be corrected exactly. On the contrary, for large  $\sigma$ , the corrected error asymptotes to a finite value:

$$\mathcal{E}_c = \sqrt{2/3} N \sigma^2 = \frac{1}{\sqrt{6}} \mathcal{E}_0^2 \quad (2)$$

This form can be derived rigorously from the distribution of MZI splitting angles over the Haar measure [23, 29], where errors arise solely from MZIs whose target splitting ratios cannot be realized in the imperfect hardware. Since  $\mathcal{E}_c \propto \mathcal{E}_0^2$ , we can say that self-calibration leads to a *quadratic* suppression of errors: the smaller the initial error, the greater the benefit of error correction.

Fig. 4(b-c) tests the scalability of the algorithm by varying the mesh size  $N$ . Fig. 4(b) shows that, as expected, as the mesh size grows, the corrected error asymptotes to the quadratic factor Eq. (2). By plotting  $\mathcal{E}_c / (\mathcal{E}_0^2 / \sqrt{6})$ , Fig. 4(c) shows the boundary between the exactly correctable small-error regime ( $\mathcal{E}_c = 0$ ) and the inexact large-error regime where Eq. (2) holds. The regimes meet where the coverage  $\text{cov}(N)$  of  $U(N)$  dips below unity [29];

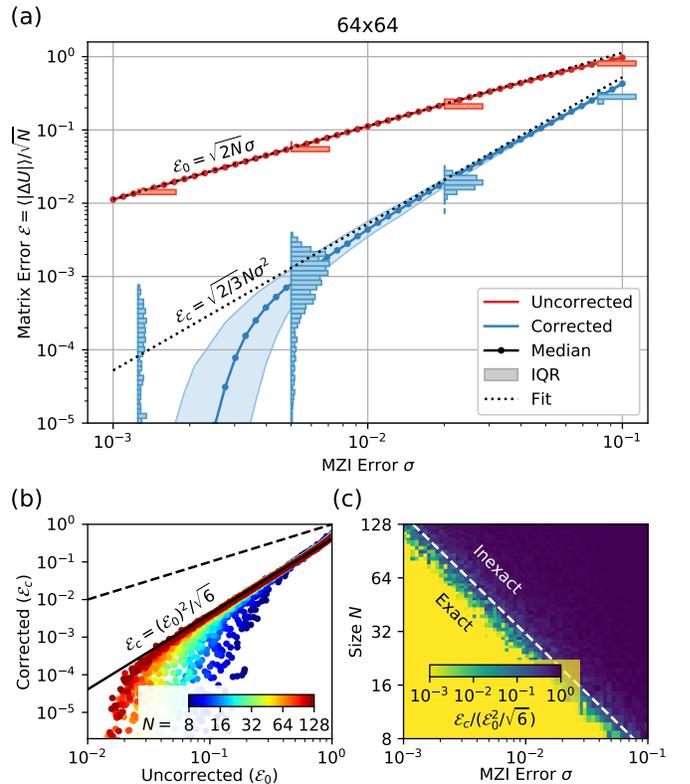


Figure 4: (a) Corrected and uncorrected matrix error as a function of  $\sigma$ ,  $64 \times 64$  CLEMENTS mesh. (b) Scaling with mesh size, showing the quadratic suppression of errors due to correction. (c) Boundary between the regimes of exact and inexact error correction.

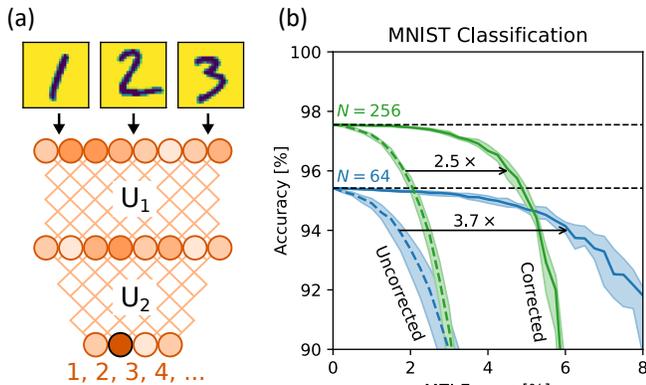


Figure 5: (a) 2-layer DNN for MNIST classification where synaptic connections are represented by CLEMENTS meshes. (b) Simulated classification accuracy as a function of network size  $N$  and hardware MZI error  $\sigma$ .

we have previously shown that  $\text{cov}(N) \sim e^{-N^3\sigma^2/3}$  [23]; therefore the boundary lies at roughly  $N^3\sigma^2 = 3$  (dashed curve in Fig. 4(c)).

To illustrate the benefits of this error reduction, we consider as an example deep neural network (DNN) inference on optical hardware. DNNs process data in a sequence of layers, each consisting of (linear) synaptic connections and (nonlinear) neuron activation (Fig. 5(a)). One exciting possibility is to use photonics to accelerate this process: encode the input in optical amplitudes, use a programmable MZI mesh to implement the synaptic weights, and perform the activations with an all-optical (or electro-optic) nonlinearity [3]. A major challenge is that useful learning tasks require large mesh sizes ( $N > 100$ ), which are particularly susceptible to fabrication error; a recent study showed that accurate DNN inference might require unrealistic process tolerances in the hardware [24]. This challenge has spurred investigations into alternative proposals, which have their own limitations [4, 5, 30].

Fig. 5(b) illustrates the advantage of error correction in an MZI-mesh DNN accelerator. Here, input images are pre-processed by a Fourier transform and fed into a two-layer DNN, with electro-optic neuron activations [31]. Models with inner layer sizes  $N = 64$  and  $N = 256$  were trained on the MNIST digit dataset [32] using the NEUROPHOX package [33]. Details and code are available in the Supplementary Material [25, Sec. S3]. These pre-trained models were then simulated numerically on imperfect CLEMENTS meshes to calculate the classification accuracy. Applying our correction algorithm increases the error tolerance of these DNNs by over  $2\times$ . Note that directional couplers in silicon typically exhibit  $\sigma \approx 2\%$  [34]; in this regime, the uncorrected DNNs show significant degradation, while error correction restores them to their canonical accuracy. Error correction may even allow the use of broad-band multi-mode interference couplers, which typically exhibit

larger hardware errors.

We have proposed a new self-configuration technique for rectangular MZI meshes. Our technique requires only external sources and (coherent) detectors and does not rely on an accurate characterization of device errors. This method is based on the diagonalization of a unitary matrix by Givens rotations, with a specific set of measurements performed to ensure that the Givens rotations are properly implemented in the hardware. For sufficiently small hardware errors, our approach leads to perfect realization of the target matrix. For large errors, it achieves the same quadratic reduction  $\mathcal{E} \rightarrow \mathcal{E}^2/\sqrt{6}$  observed for local correction algorithms [18] and self-configuration on triangular meshes [23]. As a target application, we considered optically accelerated DNNs and showed that the proposed technique increases their robustness to hardware error, particularly in the critical region around  $\sigma \approx 2\%$  characteristic of directional couplers in silicon.

One open question is the robustness to non-unitary errors (unbalanced losses), as this and other self-configuring algorithms rely on unitarity, while realistic devices often have undesired state-dependent loss [35–37]. In addition, extensions of the algorithm to more recently developed mesh geometries [38–42] may prove useful, as some geometries are less sensitive to hardware error and may be easier to scale up to large dimensions.

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## Supplementary Material

### S1 Triangular Meshes

The key to self-configuring the CLEMENTS mesh [S1] was realizing that it could be divided into two triangles with a phase screen in the center:  $U = VDW$ . By configuring one diagonal at a time, alternating between  $V$  and  $W$ , we could zero all the elements of the target matrix  $X = V^\dagger U W^\dagger$ , thus realizing the desired unitary. This procedure is simplified when configuring RECK [S2], which can be expressed in terms of a single triangle:

$$U = D \left( \underbrace{\prod_{mn} T_{mn}}_W \right) \text{ or } \left( \underbrace{\prod_{mn} T_{mn}}_V \right) D \quad (\text{S1})$$

The first case  $U = DW$  corresponds to a mesh with an output phase screen (Fig. S1(a)), while the mesh for  $U = VD$  has an input phase screen (Fig. S1(b)). The algorithm in the main text simplifies because we may substitute  $V = I$  [resp.  $W = I$ ]. This leads to two cases:

1. For the first case (Fig. S1(a)), we work downstream from the leftmost MZI. For example, we can work down the falling diagonals, with the order given in the figure. Each step adds an MZI to  $W \rightarrow T_{mn}W$ , which updates the target matrix  $X \rightarrow XT_{mn}^\dagger$  to zero an element in the upper triangle. With input field  $a_{\text{in}} = w_j^*$  (the  $j^{\text{th}}$  column of  $W^\dagger$ ), the parameters  $(\theta, \phi)$  are set to zero the field at output  $i$ , where  $(i, j)$  is the index of the element  $X_{ij}$  being zeroed.
2. For the second case (Fig. S1(b)), we work upstream from the rightmost MZI, which performs the update  $V \rightarrow T_{mn}V$ ,  $X \rightarrow T_{mn}^\dagger X$ . With light sent into the  $i^{\text{th}}$  input,  $(\theta, \phi)$  are chosen to zero the dot product between the output field and  $v_i$  (the  $i^{\text{th}}$  column of  $V$ ).

After the crossings are configured, the phases of  $D$  can be obtained by inspection.

The MZI order in Fig. S1 is not unique. Any order that preserves causality (the set of configured and unconfigured MZIs must be causally separated) will produce a valid self-configuration.

Like the configuration of the CLEMENTS rectangle, the procedure above is designed, at each time step, to properly set the configured MZIs in the red [resp. blue] block to realize  $W$  [resp.  $V$ ]. The procedure in Fig. 1(a) is closely related to the Reversed Local Light Interference Method (RELLIM) [S3]. However, there are two important differences. First, RELLIM inputs columns of  $U^\dagger$ , while our scheme inputs columns of  $W^\dagger$ . As the MZIs are configured,  $W$  changes. Second, RELLIM assumes the existence of internal power detectors after each MZI (or the ability to pre-calibrate the downstream mesh so

that internal fields can be read off from the outputs). By inputting a row of the target  $W^\dagger$ , light will exit the red block along only the  $j^{\text{th}}$  and  $(j+1)^{\text{th}}$  channels (provided all upstream MZIs are correctly set). The former, which is set to zero by varying  $(\theta, \phi)$ , is read off directly from the  $i^{\text{th}}$  output.

The procedures in Fig. S1(a-b) are reciprocal to each other and can also be related to the ‘‘ratio method’’ described in Ref. [S4], since the process of zeroing matrix elements never depends on absolute amplitudes, only on their ratios. Moreover, the ratio method is also robust in the presence of large errors and achieves the same quadratic error reduction. However, when configuring each MZI, the ratio method required a sweep of the upstream phase shifter in order to subtract the common amplitude  $\vec{a}$ , a procedure that is not necessary here.

Fig. S2 plots the matrix error  $\mathcal{E} = \|\Delta U\|/\sqrt{N}$  as a function of MZI error  $\sigma$  for the RECK mesh. The result is identical to the case of the CLEMENTS mesh, Fig. 4, following the curves  $\mathcal{E}_0 = \sqrt{2N}\sigma$ ,  $\mathcal{E}_c = \sqrt{2/3N}\sigma^2$  predicted by theory [S4]. Over the Haar measure, the distribution

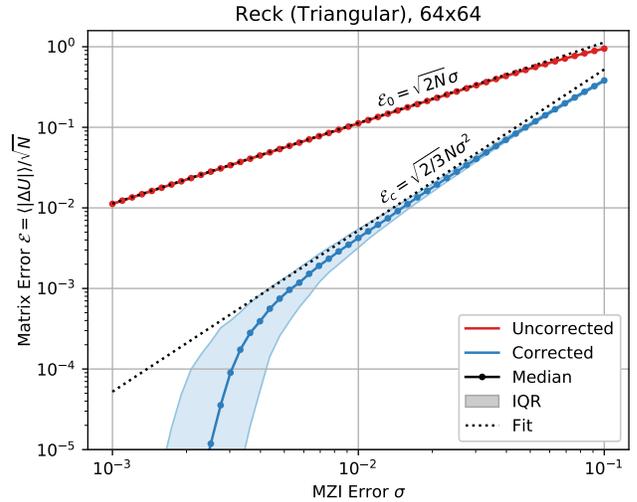


Figure S2: Corrected and uncorrected matrix error as a function of MZI error  $\sigma$ ,  $64 \times 64$  RECK mesh.

of MZI splitting angles is the same for both mesh geometries up to a reordering of the MZIs [S5]; therefore, this correspondence is unsurprising.

The self-configuration procedures for RECK and CLEMENTS can be mapped to a general-purpose subroutine that self-configures any MZI mesh of the form  $U = VDW$ , provided that the geometry admits a matrix diagonalization by way of Givens rotations. This algorithm has been implemented in PYTHON with NUMBA extensions for numerical efficiency, and is available as part of the MESHES package [S6]

## S2 Correlated Errors

In realistic MZI meshes, the beamsplitter errors  $\alpha_n, \beta_n$  will be strongly correlated, since the process variations that lead to errors (waveguide thickness and spacing, partial etch depth, slab height) all have correlation lengths much longer than the size of an MZI. In general, the matrix error  $\langle \|\Delta U\|^2 \rangle$  will depend both on the error amplitudes ( $\langle \alpha_n^2 \rangle, \langle \beta_n^2 \rangle$ ) as well as their correlations ( $\langle \alpha_m \alpha_n \rangle$ , etc.). For an individual matrix  $U$ , the dependence on correlations can be significant. However, we have previously shown that, in an *ensemble average* over the Haar measure, this dependence becomes very small for most inter-MZI correlations because of the random phase shifts between pairs of MZIs [S4, Appendix A]. Only intra-MZI correlations  $\langle \alpha_n \beta_n \rangle$  have a significant effect on the ensemble-averaged matrix error.

Consider the extreme case of full correlation  $\alpha_n = \beta_n = \mu$ . This case is realized, for instance, when the dominant error source arises from operating the mesh away from the coupler design wavelength. In Ref. [S4], the coverage,

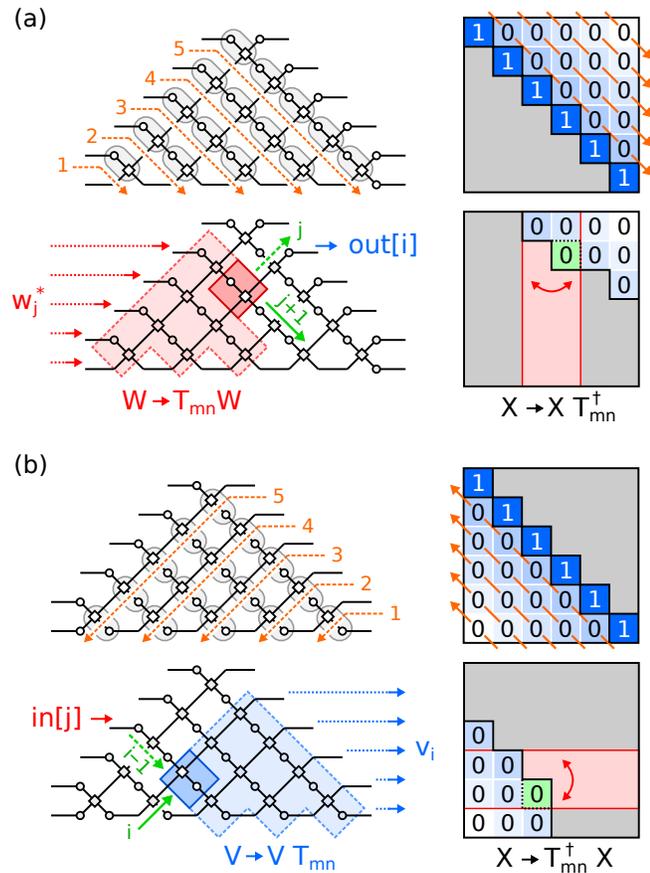


Figure S1: Self-configuration procedure for the triangular RECK mesh. The procedure depends on whether the mesh layout has (a) an output phase screen, or (b) an input phase screen.

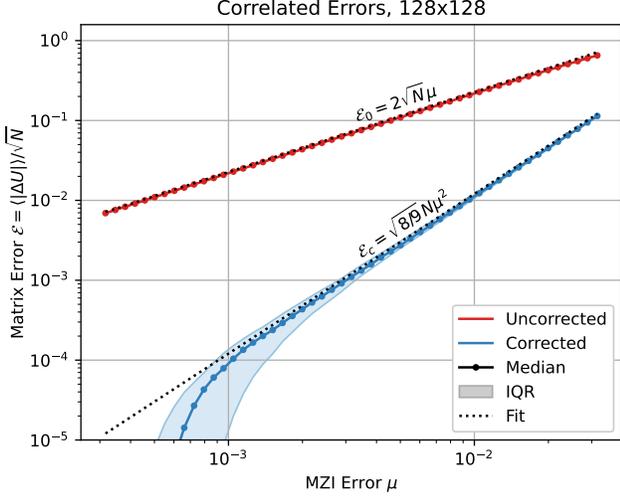


Figure S3: Corrected and uncorrected matrix error as a function of correlated MZI error amplitude  $\mu$ ,  $128 \times 128$  CLEMENTS mesh.

uncorrected error, and corrected error are calculated to be:

$$\text{cov}(N) = e^{-(2/3)N^3\mu^2} \quad (\text{S2})$$

$$\mathcal{E}_0 = 2\sqrt{N}\mu \quad (\text{S3})$$

$$\mathcal{E}_c = \sqrt{8/9}N\mu^2 \quad (\text{S4})$$

Fig. S3 plots  $\mathcal{E}_0$  and  $\mathcal{E}_c$  against the error amplitude  $\mu$  for a  $128 \times 128$  CLEMENTS mesh. Small residual dependences on correlation (proportional to  $\theta_m\theta_n$ ) lead to a slight deviation in  $\mathcal{E}_0$ , while the theoretical curve for  $\mathcal{E}_c$  matches very accurately. The behavior is qualitatively very close to that in the uncorrelated case.

### S3 Neural Network Model

The optical neural network model is based on the architecture described in Ref. [S7]. Images from the MNIST digit dataset are preprocessed with a Fourier transform, which is cropped to a  $\sqrt{N} \times \sqrt{N}$  window, where  $N$  is a model parameter that quantifies the size of the neural network. The light from this window ( $N$  input neurons) is fed into a two-layer optically accelerated DNN. This DNN consists of a single inner layer and two  $N \times N$  unitary circuits, represented by CLEMENTS meshes.

The activation function at the inner layer is realized with an electro-optic nonlinearity: a fraction of each output field is fed into a detector that drives a Mach-Zehnder modulator, while the remaining light passes through the modulator [S8]. This implements the activation function:

$$f(E) = \sqrt{1 - \alpha} e^{-i(g|E|^2 + \phi - \pi)/2} \cos\left(\frac{1}{2}(g|E|^2 + \phi)\right) \quad (\text{S5})$$

where  $\alpha$  is the power tap fraction,  $g$  is the modulator phase induced per unit optical power, and  $\phi$  is the phase in the absence of power. Here, we choose  $\alpha = 0.1$ ,  $g = \pi/20$ , and  $\phi = \pi$ , which causes  $f(E)$  to approximate the form of a leaky ReLU in the right power regime.

Models of sizes  $N = 64$  and  $N = 256$  were trained using the NEUROPHOX package [S9]. Code and model parameters are provided in the Supplementary Material [S10].

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